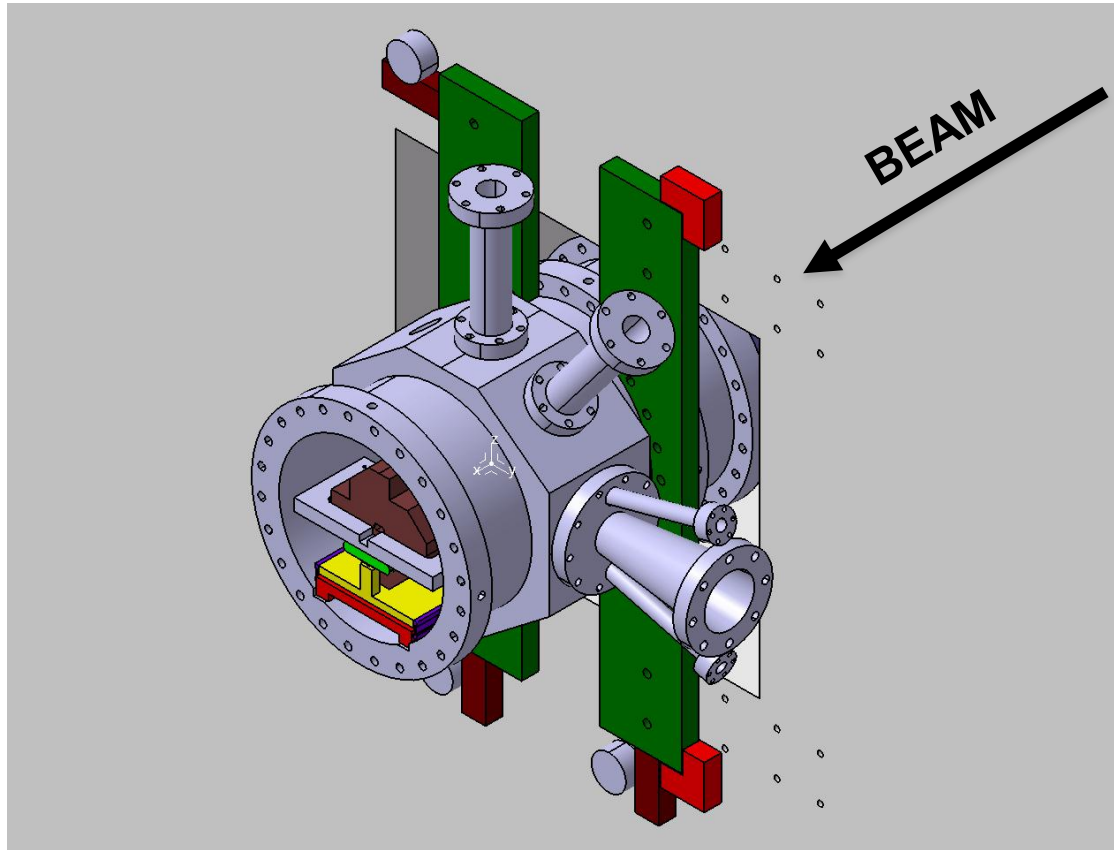
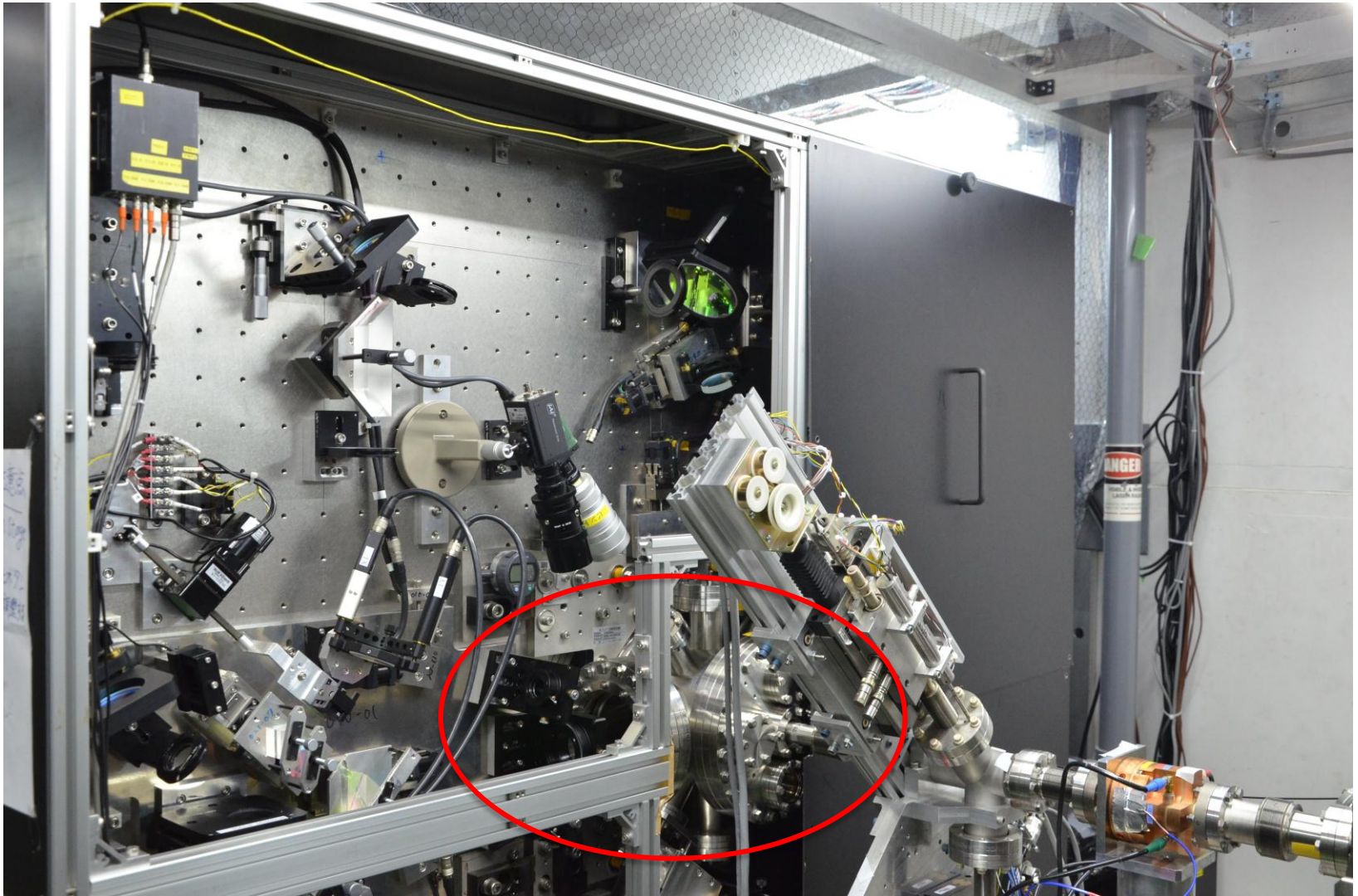


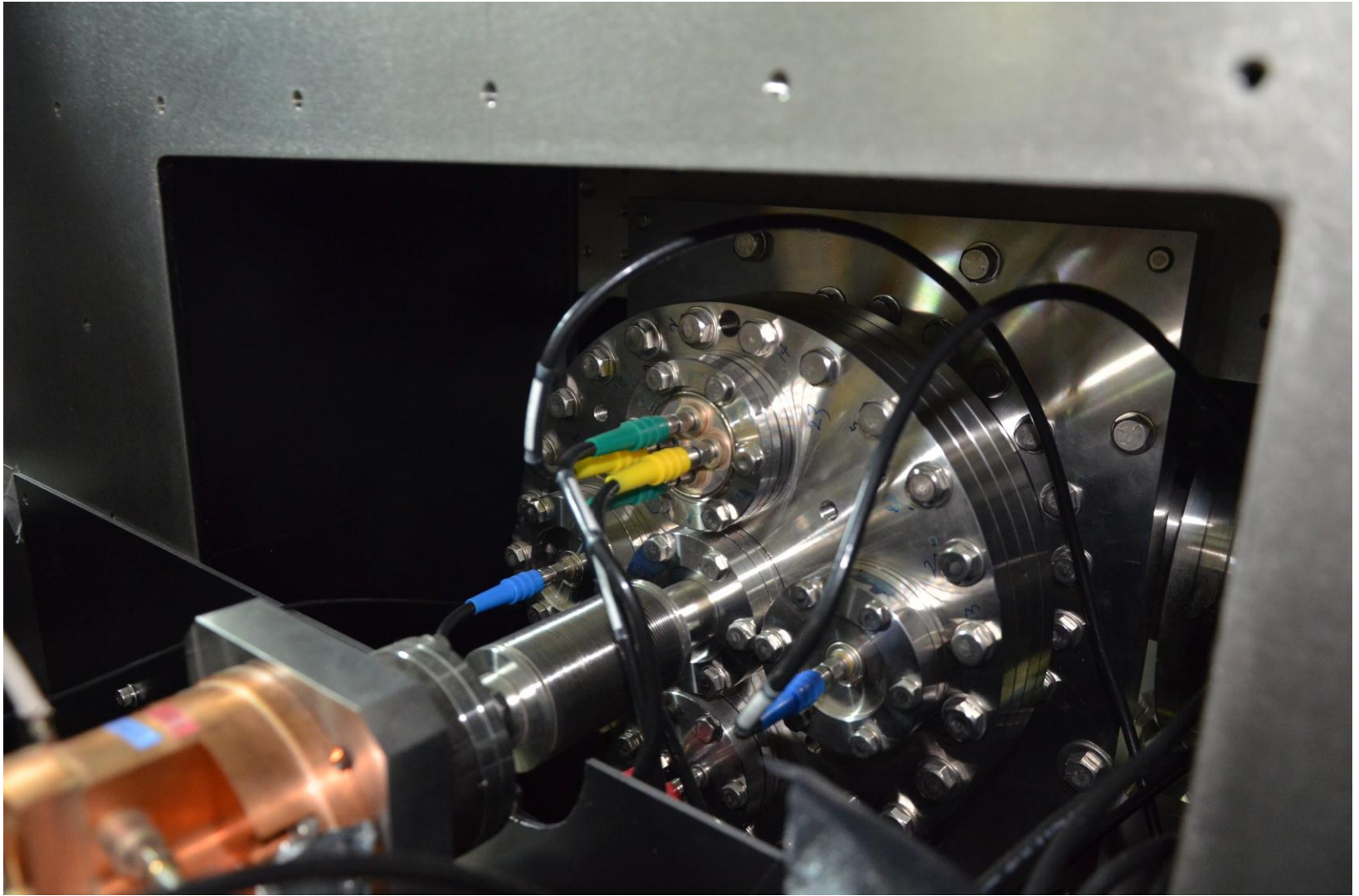
ATF2 IP Chamber Mechanical developments



LAL-IN2P3-CNRS and Paris-Sud Orsay University
Frédéric BOGARD, Sandry WALLON – 19 march 2011



"FFT'B" IP Chamber re-used at ATF2-KEK - Downstream side
... Too small to place 3 BPMs



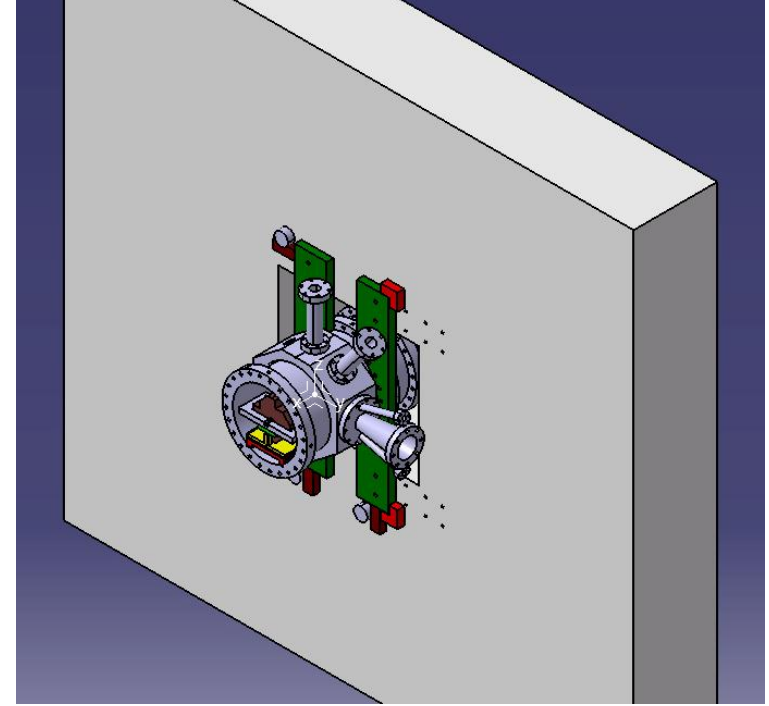
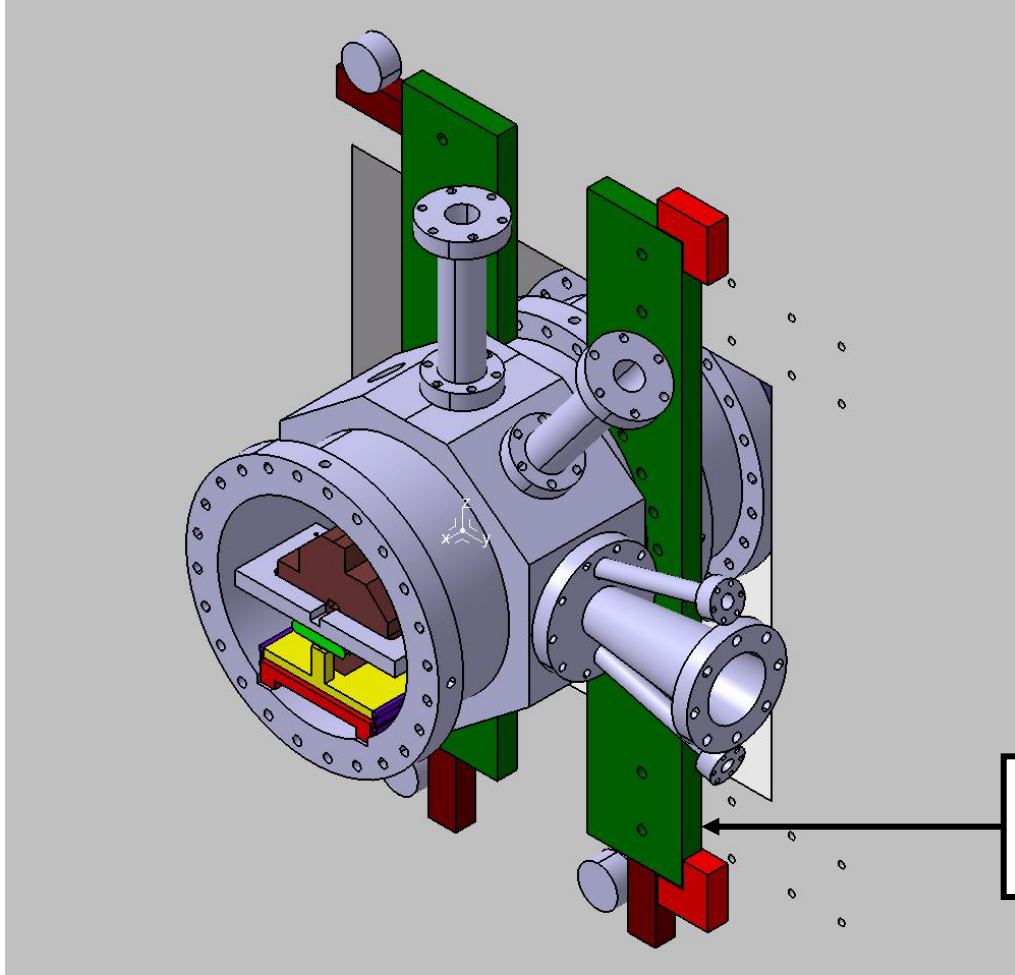
“FFTB” IP Chamber at AFT2-KEK - Upstream side



IP Chamber position
adjustment system

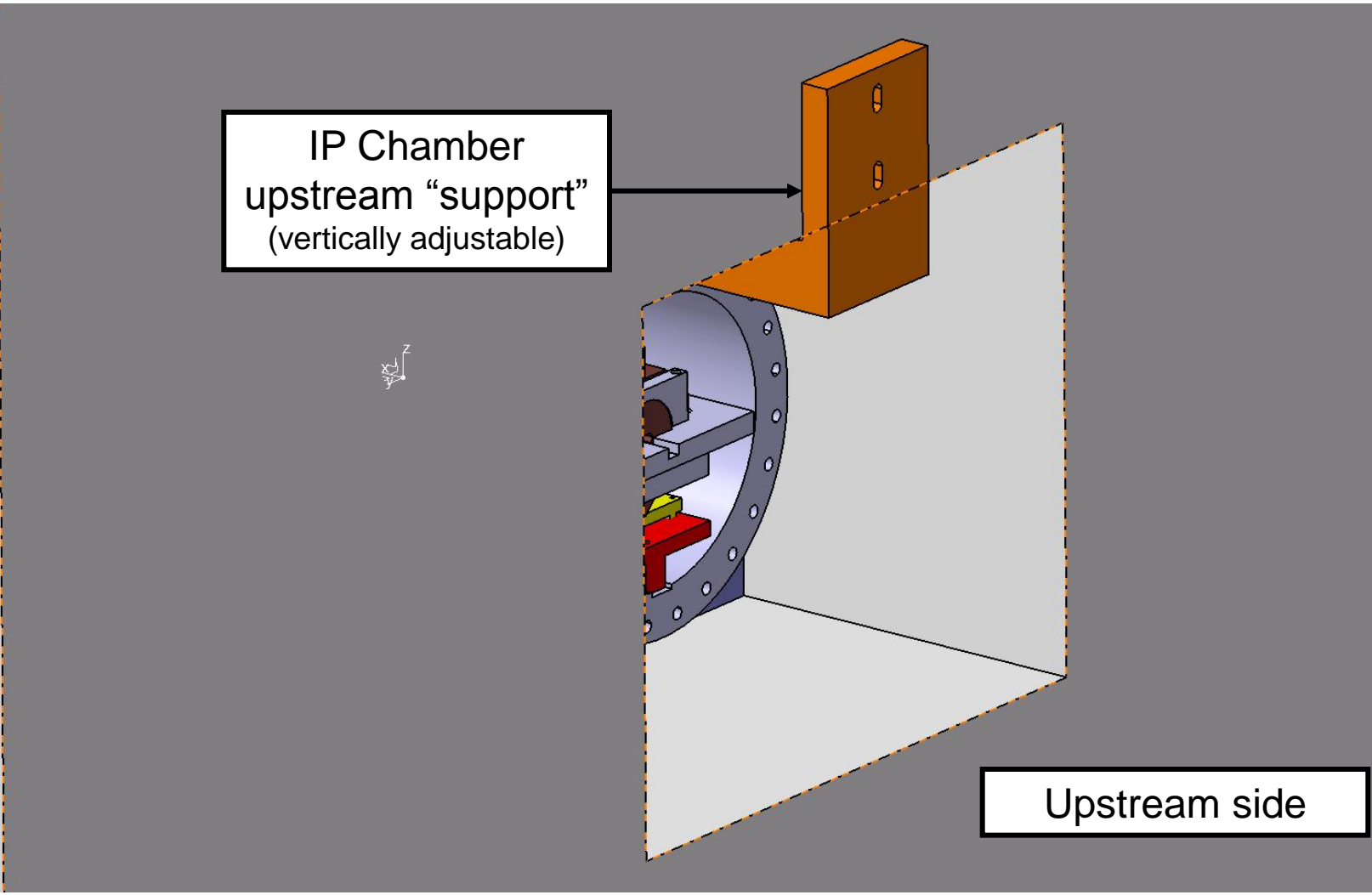
“FFTB” IP Chamber at AFT2-KEK - Downstream side

New IP chamber for 3 BPMs



IP Chamber
downstream fixture

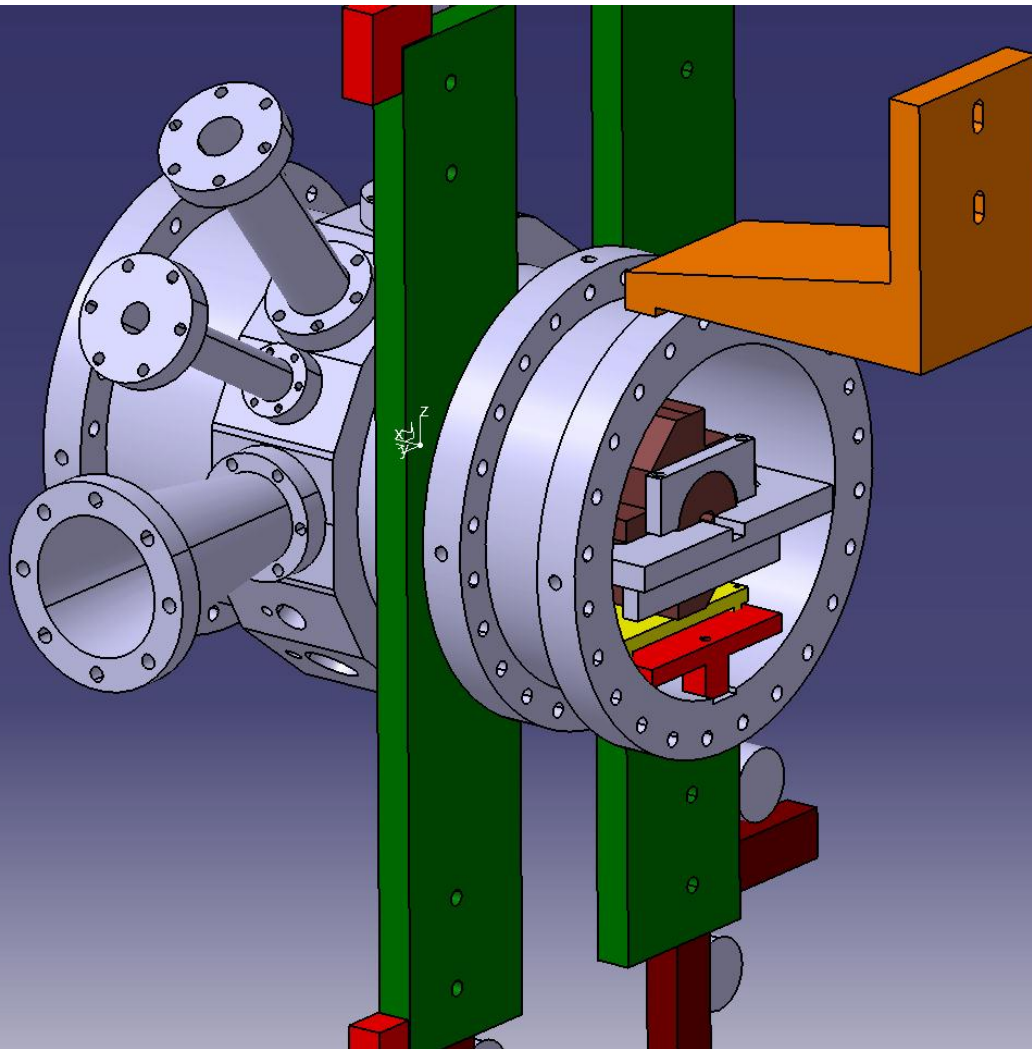
Downstream side



IP Chamber
upstream “support”
(vertically adjustable)

Upstream side

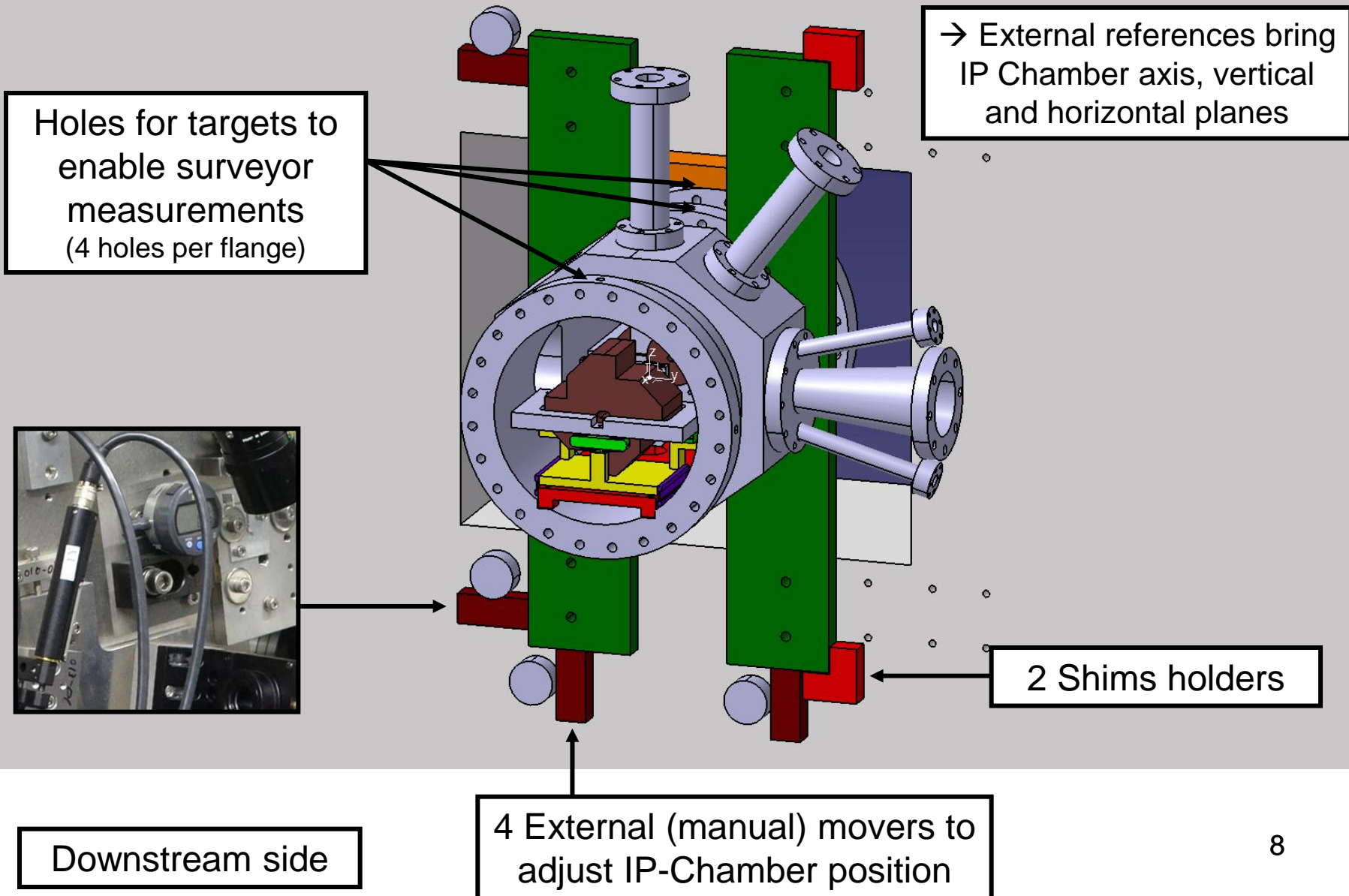
Upstream support reduces optical table deformation (both side of sandwich structure “take” the bending moment.)



Upstream side

Detail of upstream support

External alignment devices



External alignment process

Request :

- External pre-alignment for laser interferometer : 100 μm to few hundred

External alignment process

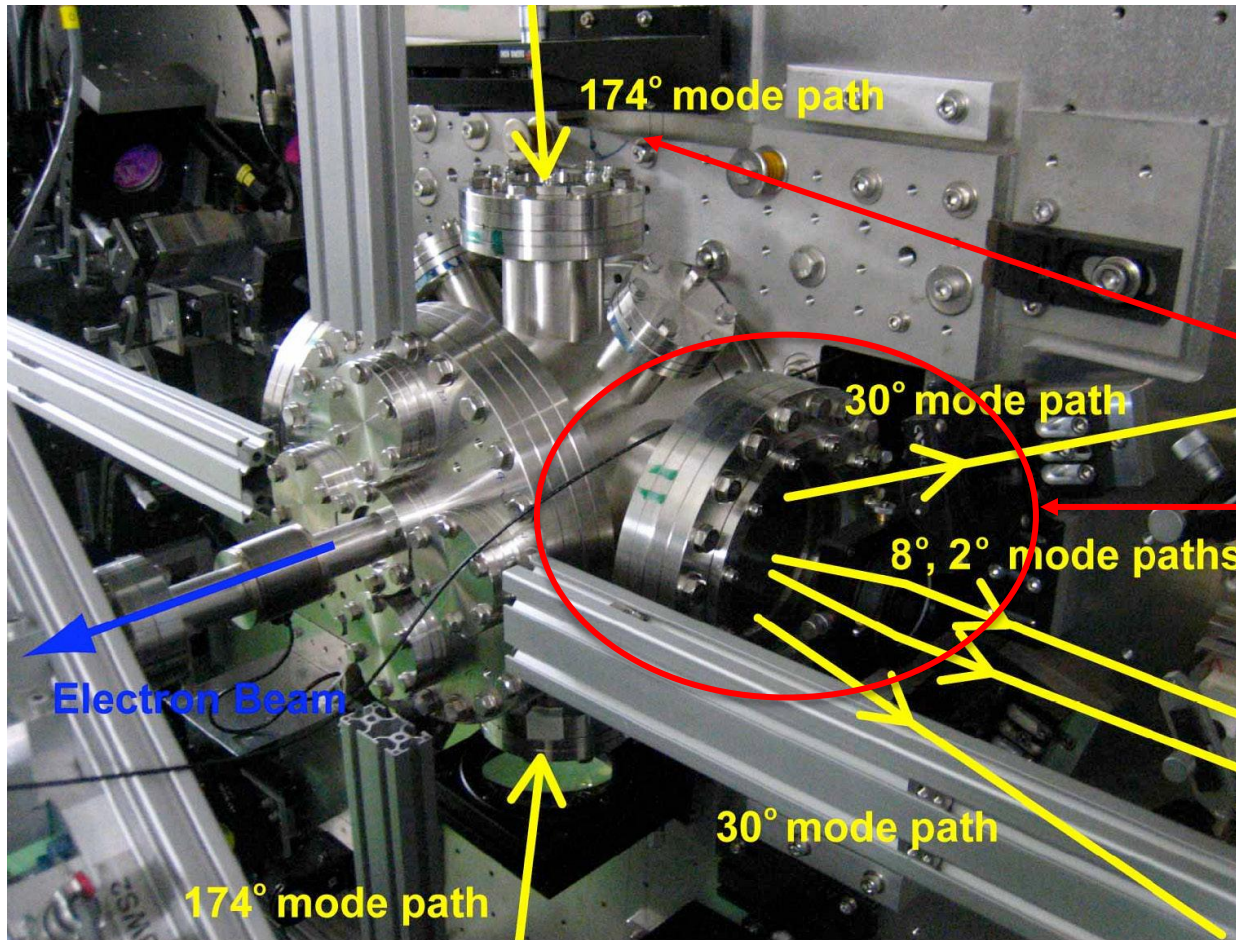
Coarse adjustment :

- External targets placed on IP Chamber' holes (3 flanges, 4 holes per flange)
 - Measurements performed with laser tracker / theodolite
 - Adjustment thanks to external movers and shims (shims to be placed into “shims holders”)
- Accuracy depends on laser tracker / theodolite precision

Fine adjustment :

- BPMs position known with regard to holes (for external targets) thanks to tridim measurements done at workshop (accuracy : 5 μm)
- Measurements performed with beam
- Adjustment thanks to external movers

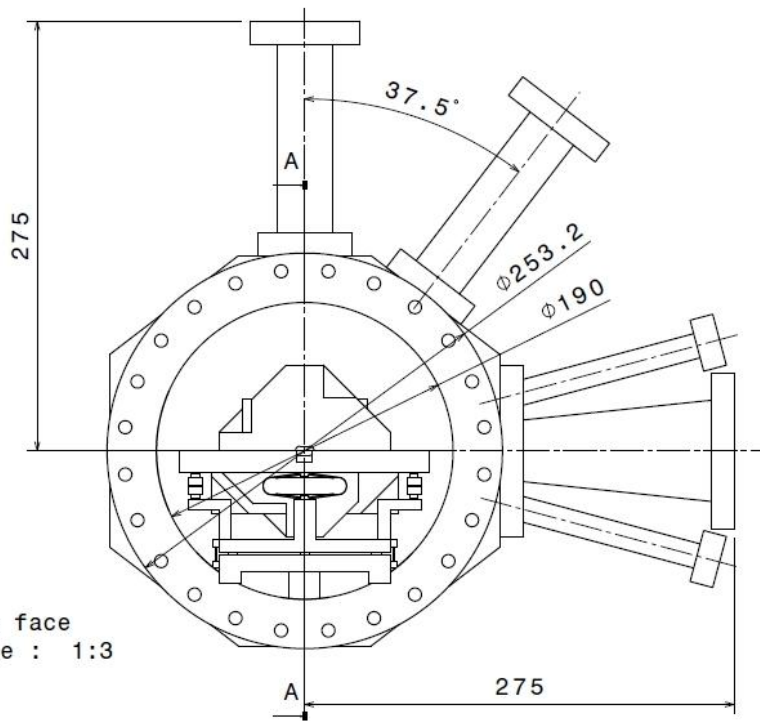
IP Chamber interfaces and dimensions



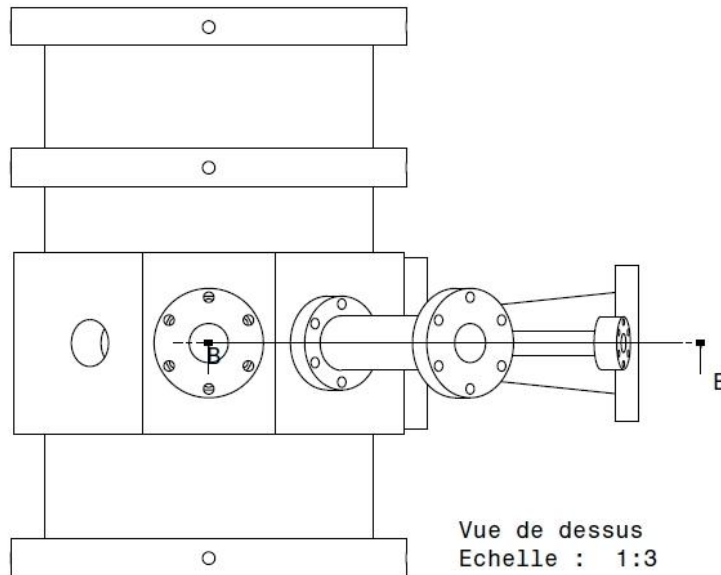
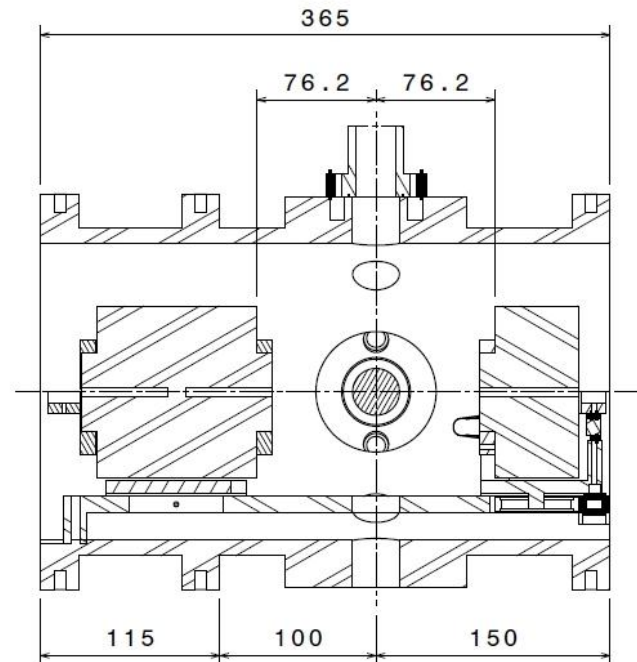
FFTB design to be improved :

- Reduce "windows to lens" distance
- Window orthogonal to 30° mode beam laser

Some angles to match

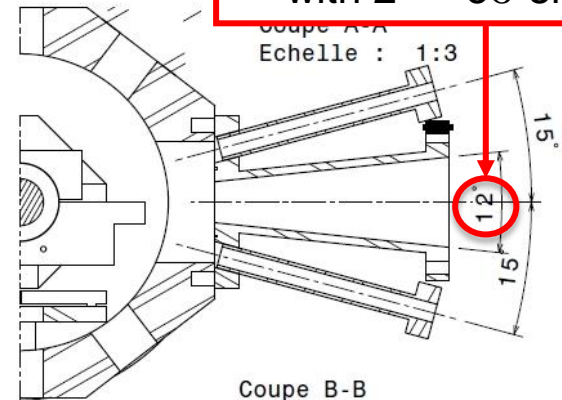


Vue de face
Echelle : 1:3



Vue de dessus
Echelle : 1:3

Allow 4° beam laser axis
with 2° "5σ envelop"



Coupe B-B
Echelle : 1:3

IP Chamber assy layout
- Angles & main dimensions



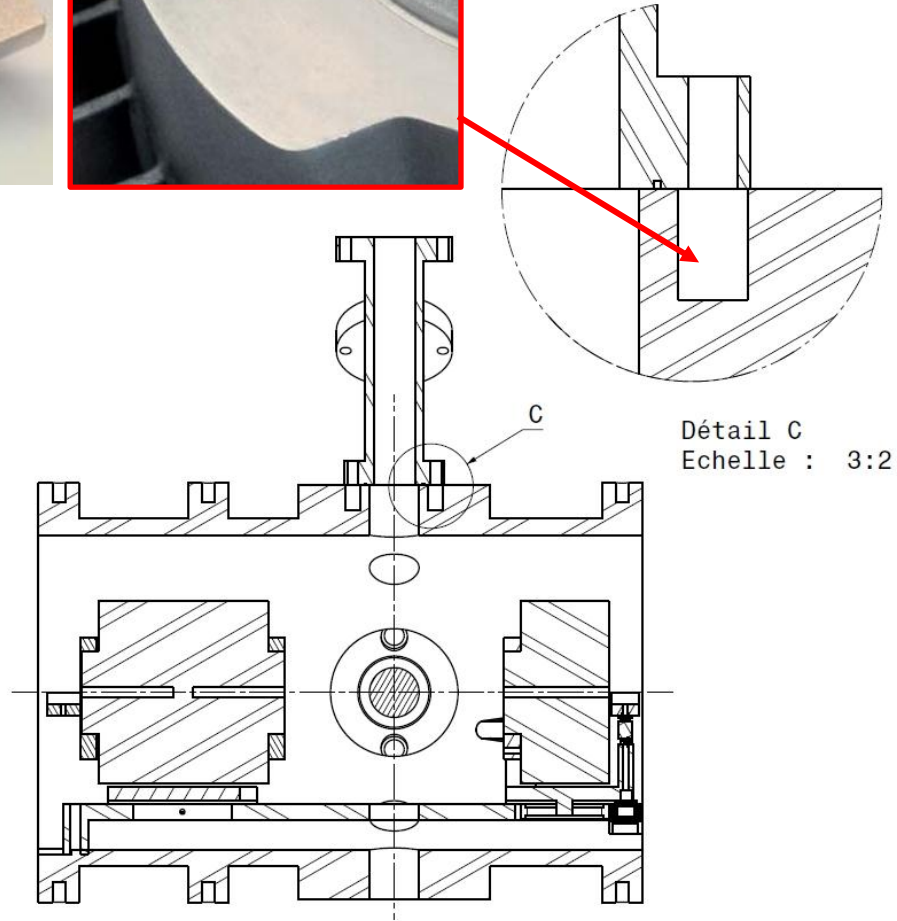
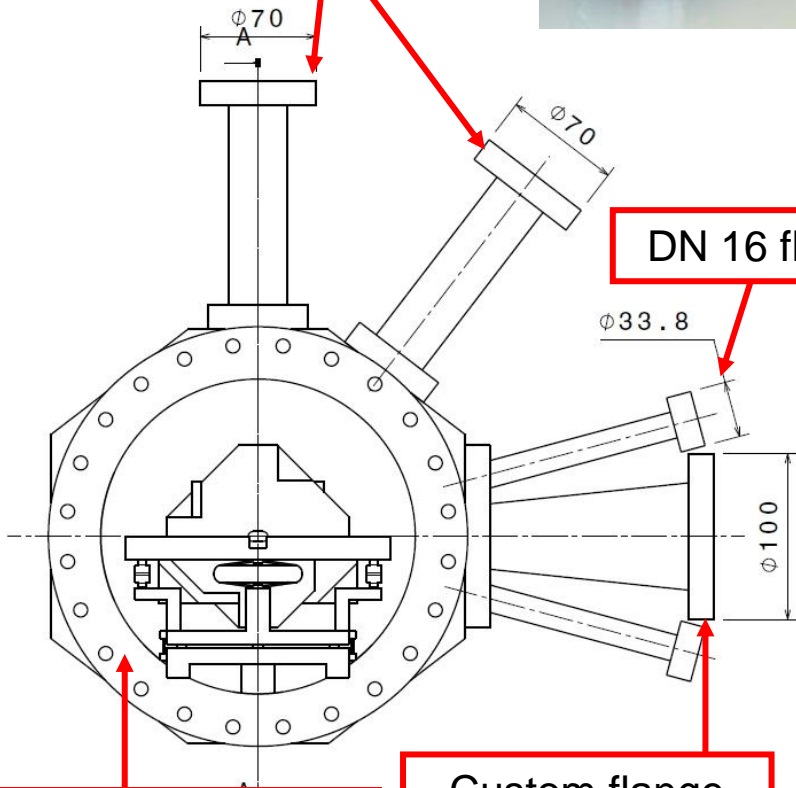
Metal (SS)
insert detail

DN 40 flanges

DN 16 flange

Custom flange

3x DN 200 flanges



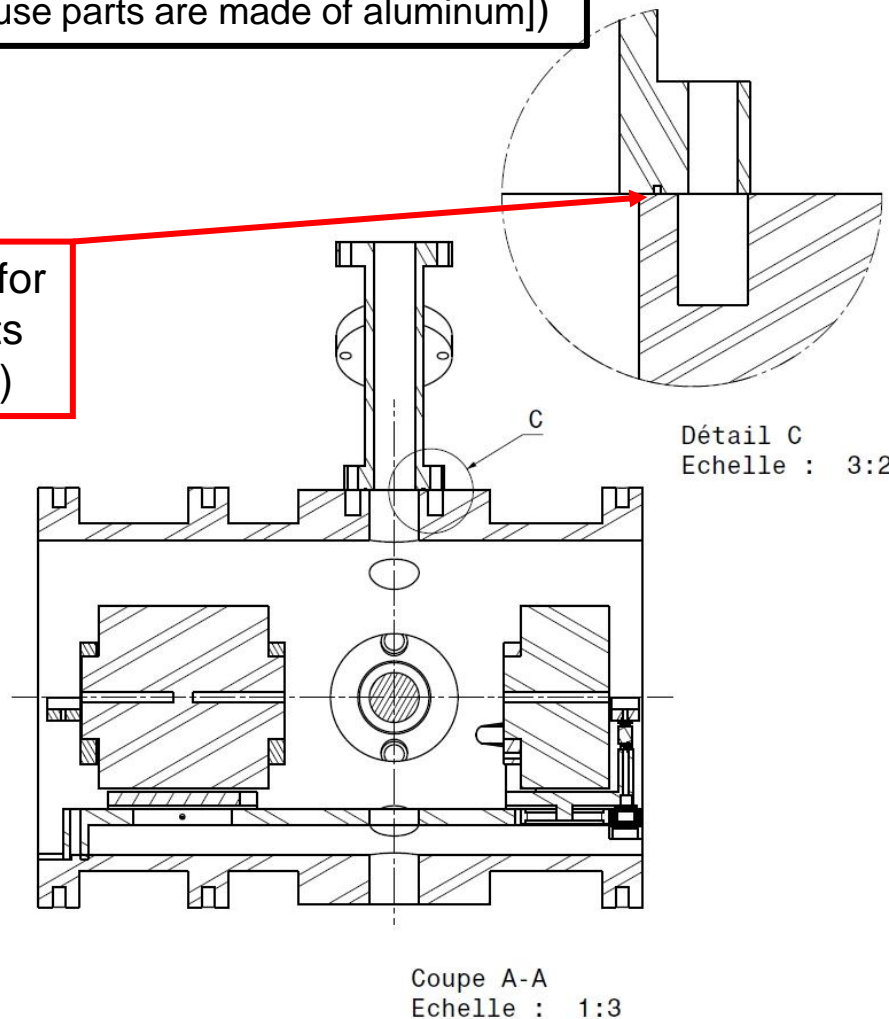
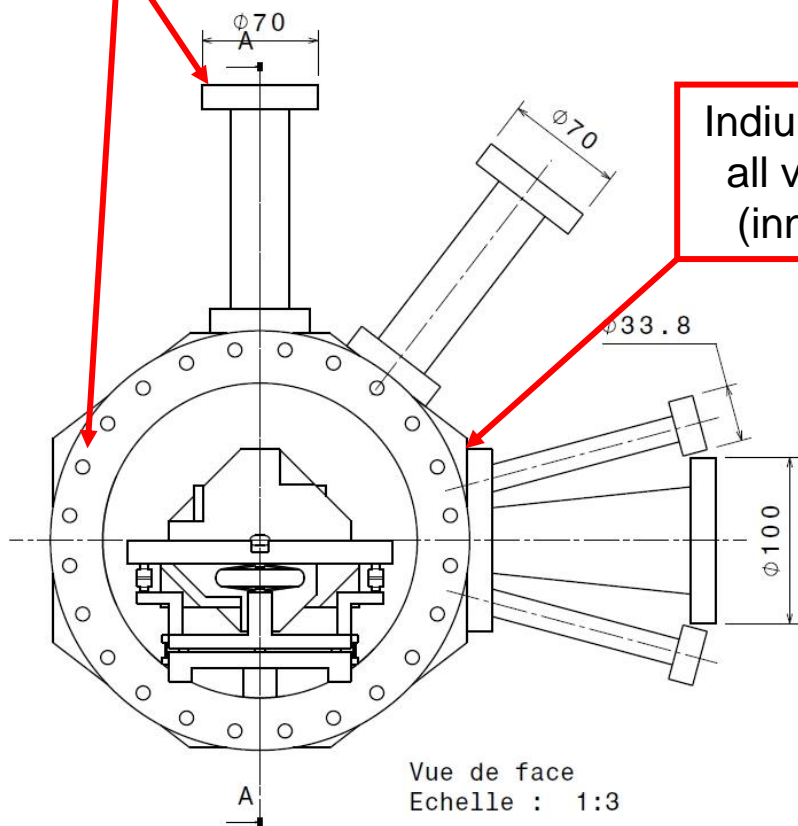
Coupe A-A
Echelle : 1:3

IP Chamber assy layout - Flanges interfaces

Flat surface used with helicoflex seals
OR
Groove used with indium seals
(outer side and DN200 flanges)

→ We advice indium seals
(helicoflex seals need surface
hardening such as anodization or
metal coating [outgassing issue
because parts are made of aluminum])

Indium seal for
all viewports
(inner side)



Détail C
Echelle : 3:2

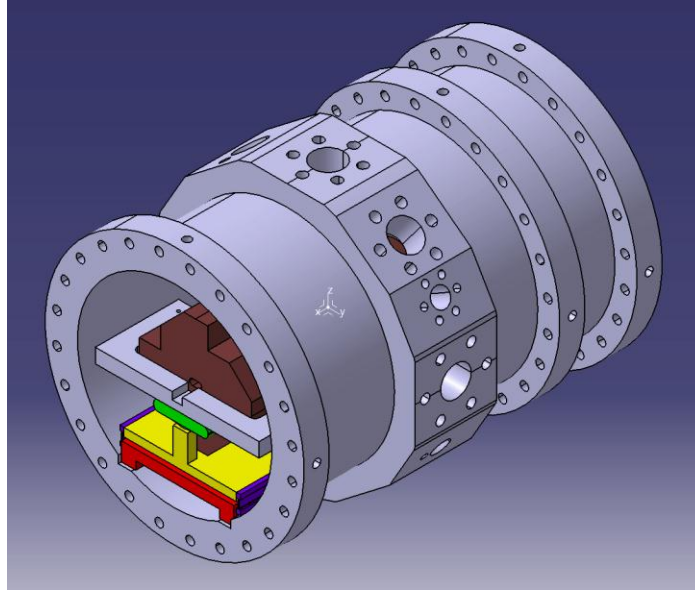
Electrical connections

Movers wires inside
IP Chamber

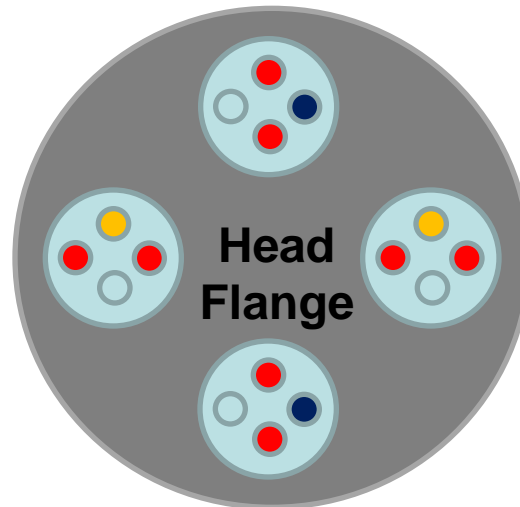
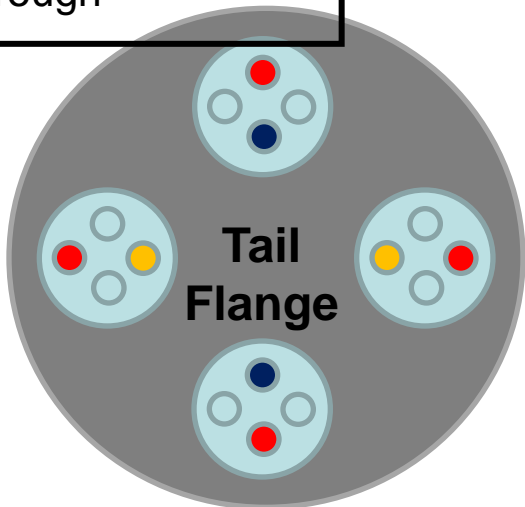
Per BPM positioning
system:

- 4+1 or 4x2 PTFE
wires (power supply)
- 4x4 PTFE wires
(strain gauges)

Wires : 30 cm long to
be crimped to
feedthrough



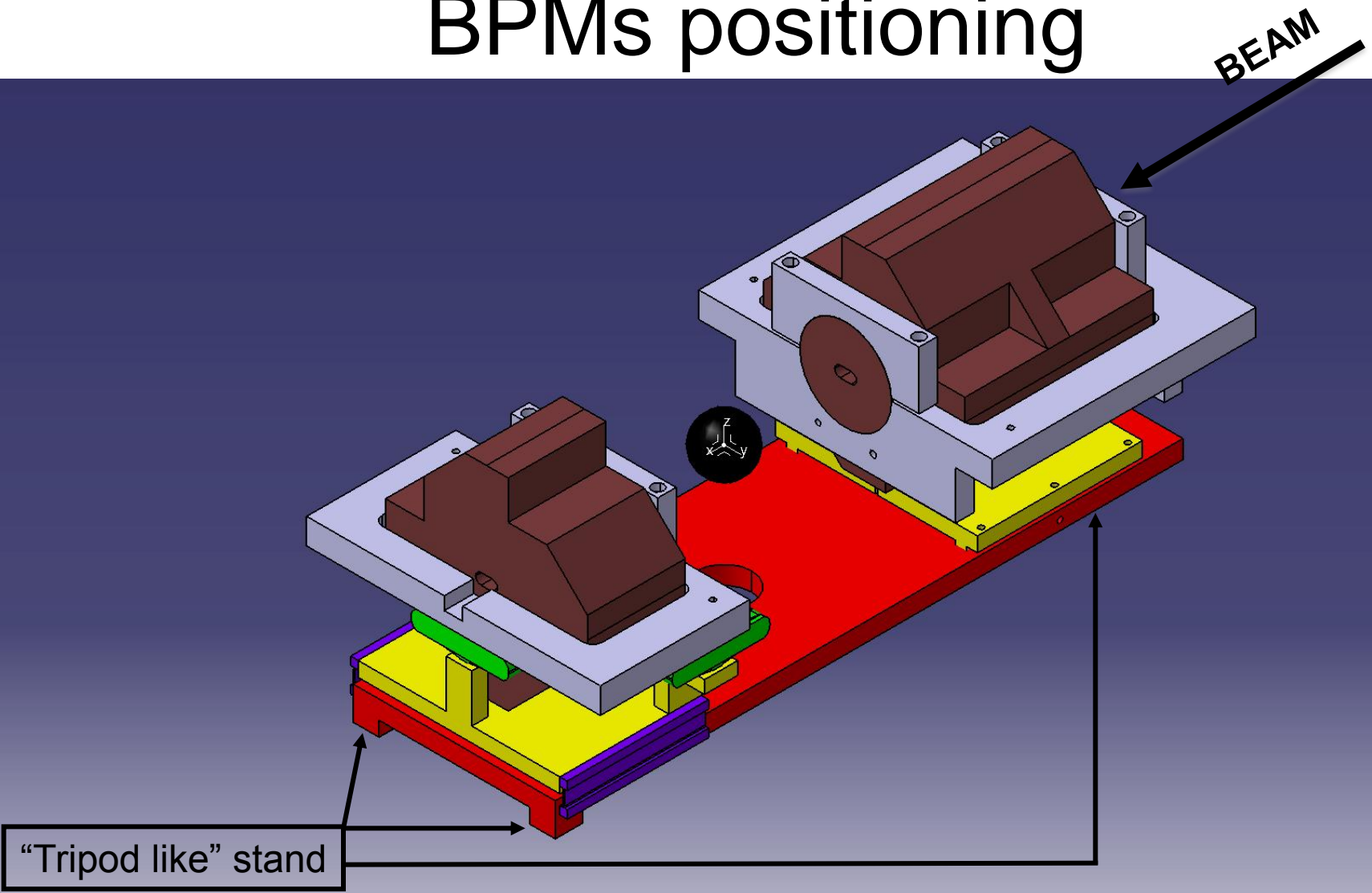
<Flanges for Chamber>



- Red dot: BPM cables
- Blue dot: Mover cables
- Yellow dot: Temperature cables

SiWon pics

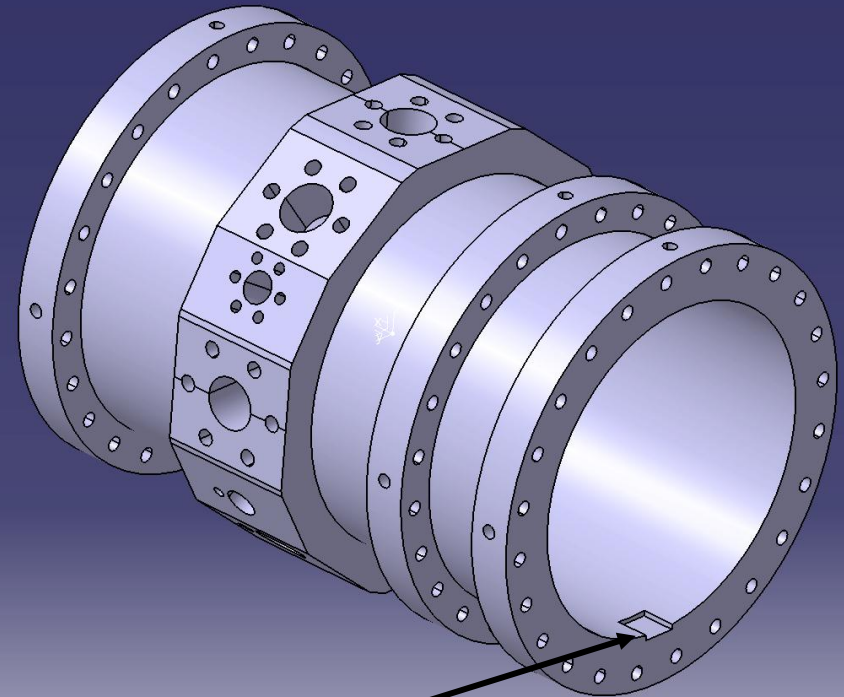
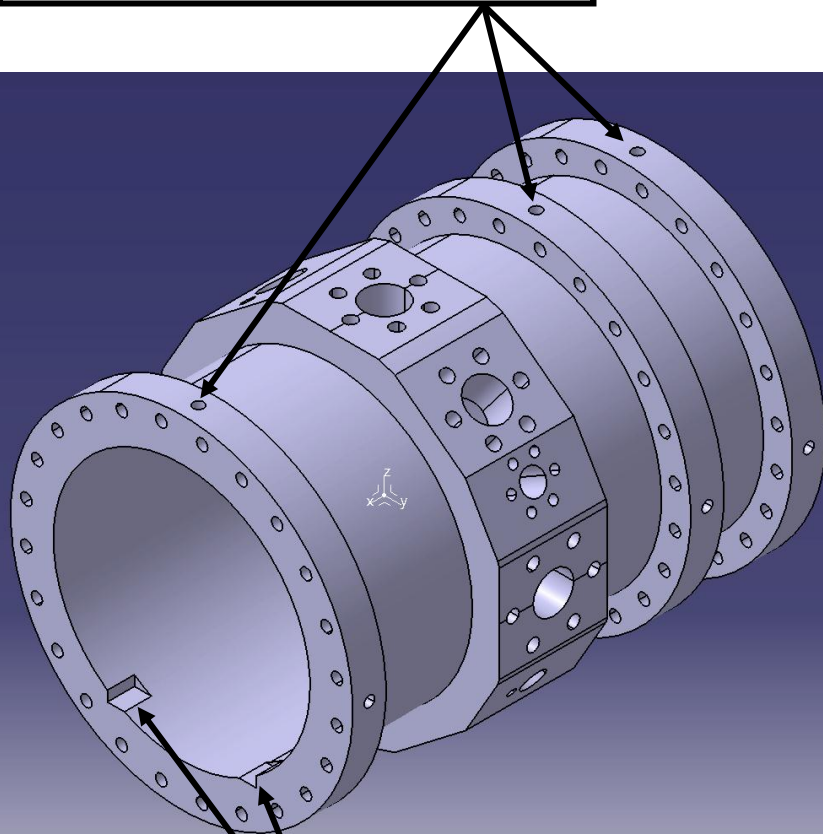
BPMs positioning



BPMs assy to be mounted in IP Chamber vessel

External references for targets - 4 holes per flange)

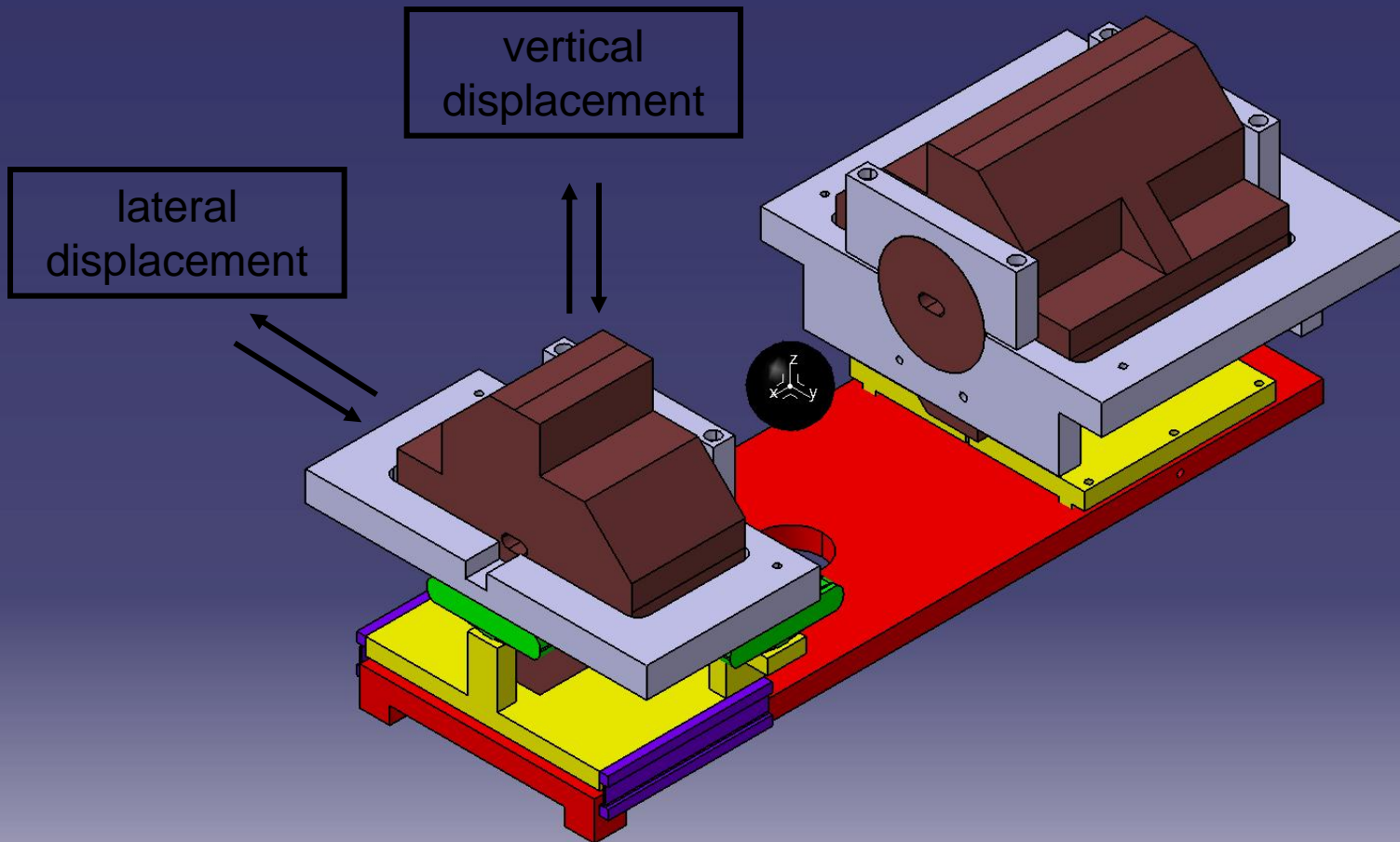
→ Internal references are known with regard to ext. ref.



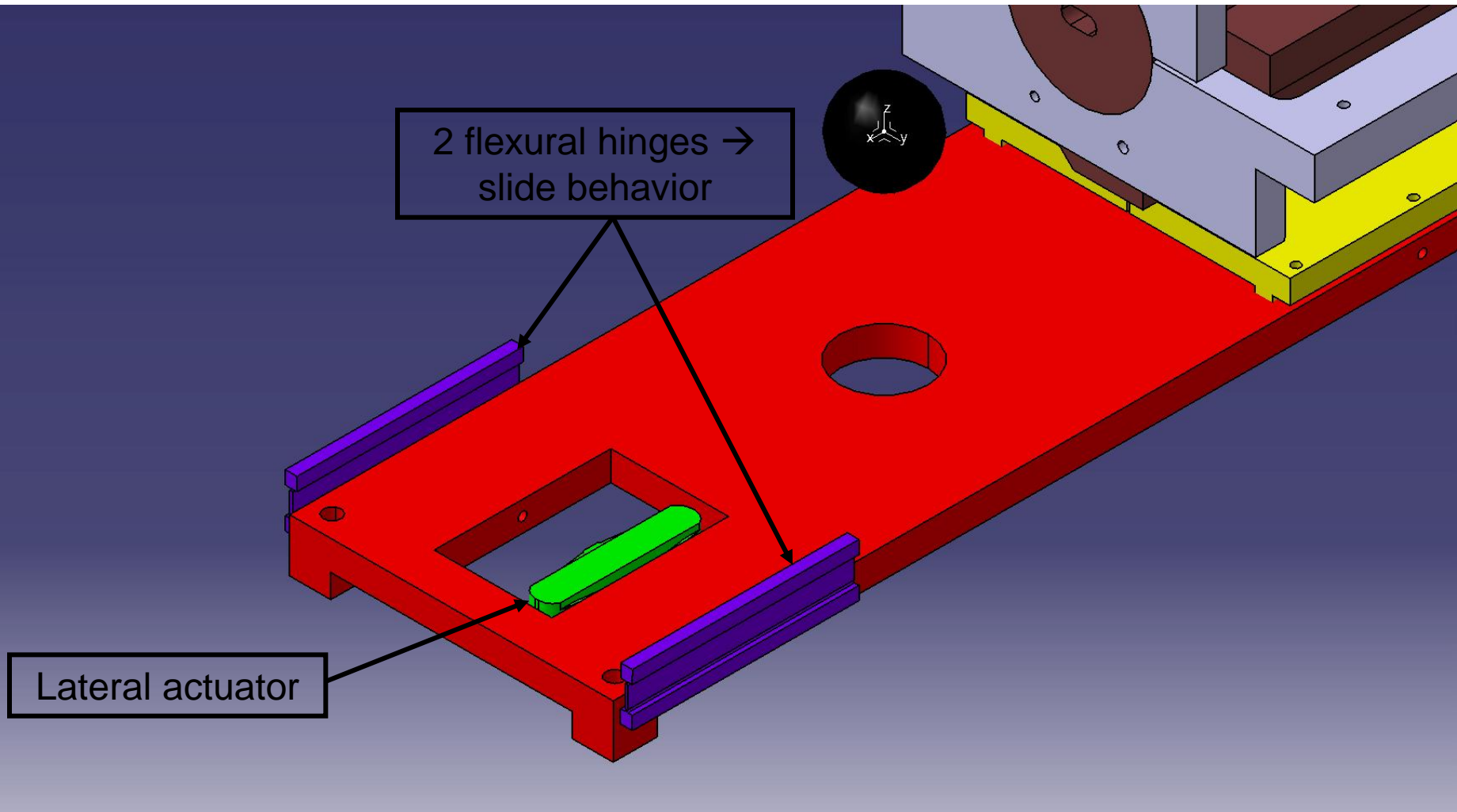
Internal references to receive BPMs assy

IP Chamber vessel

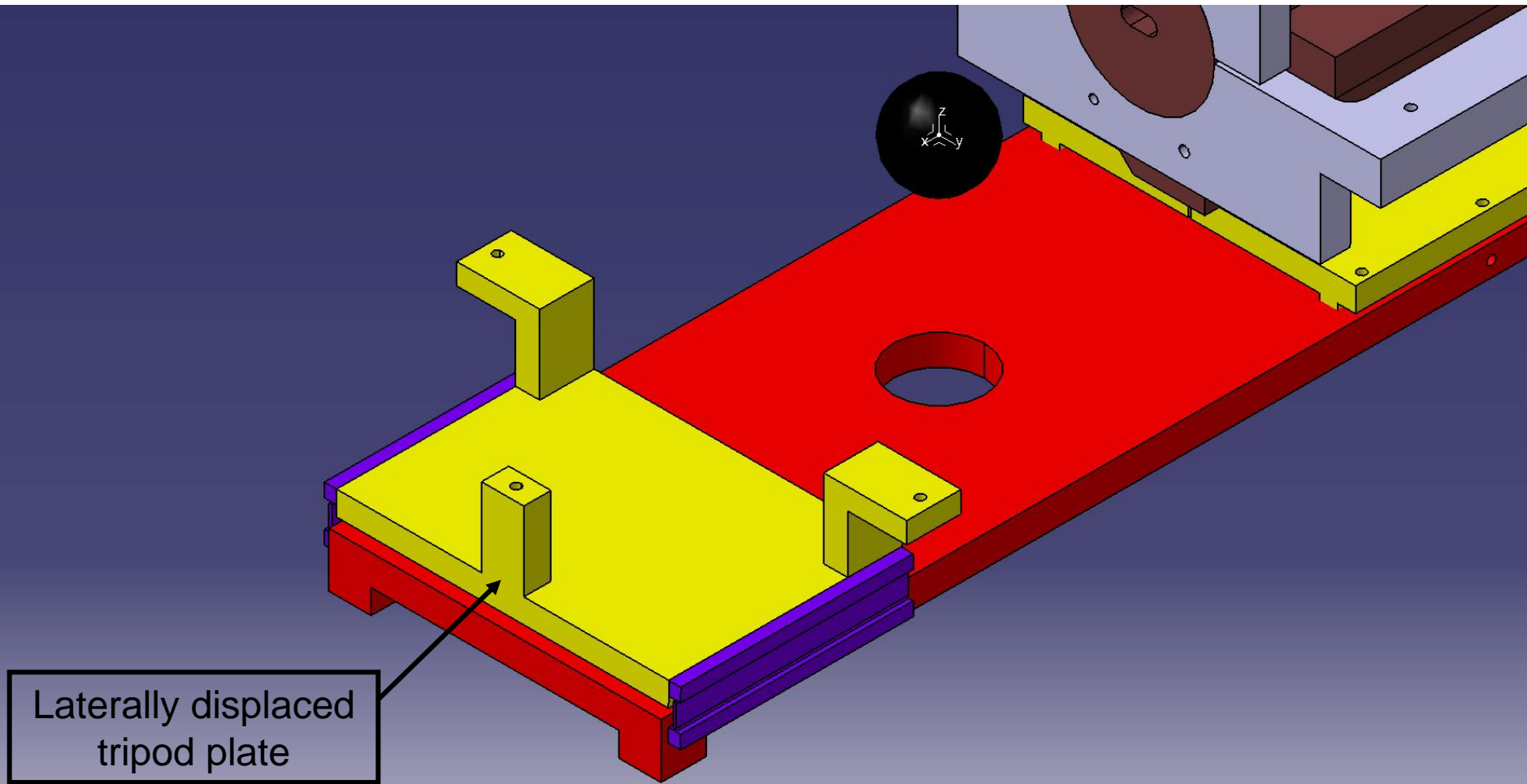
BPM3 displacements



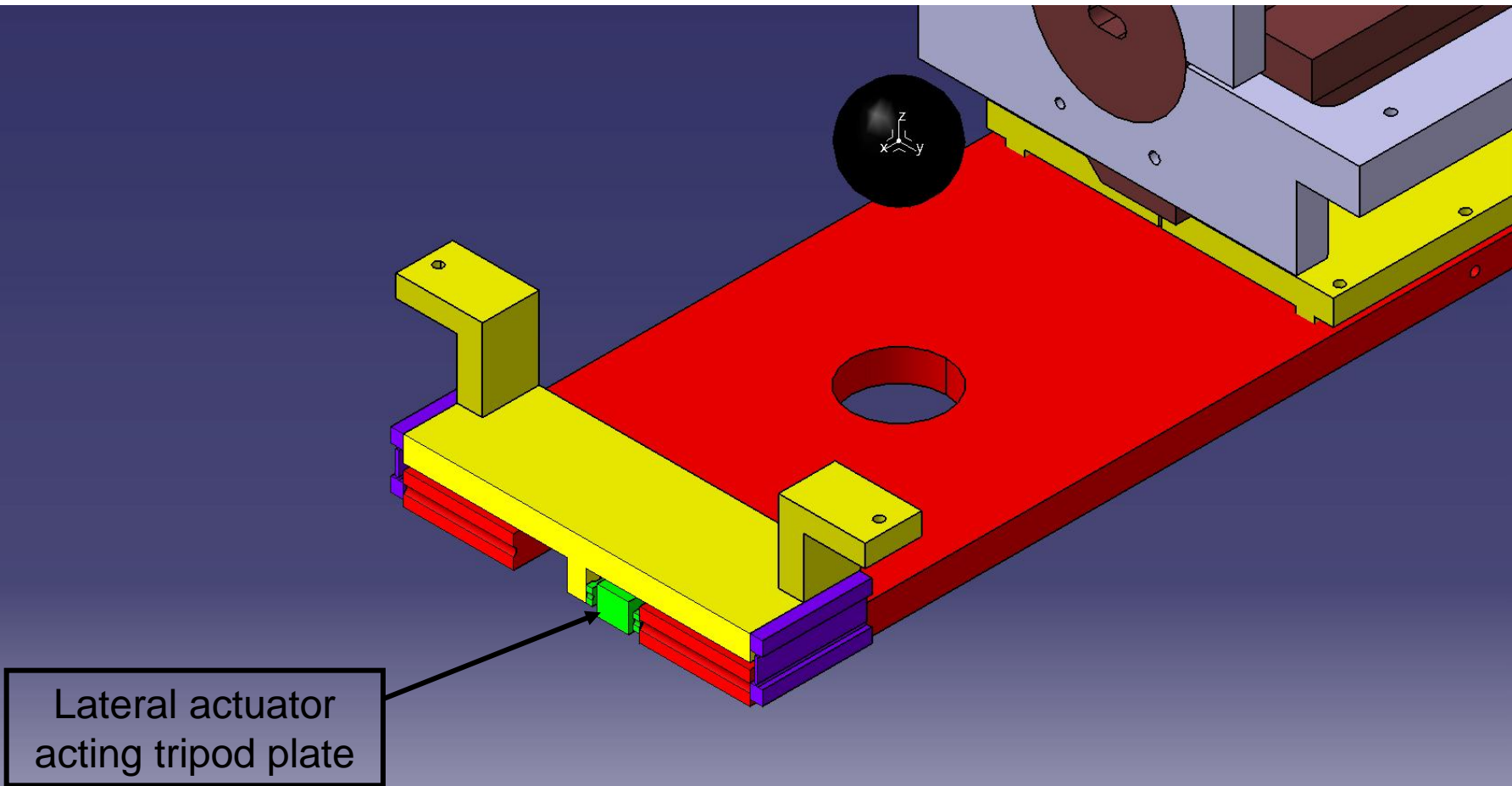
BPMs assy



Lateral displacement -1

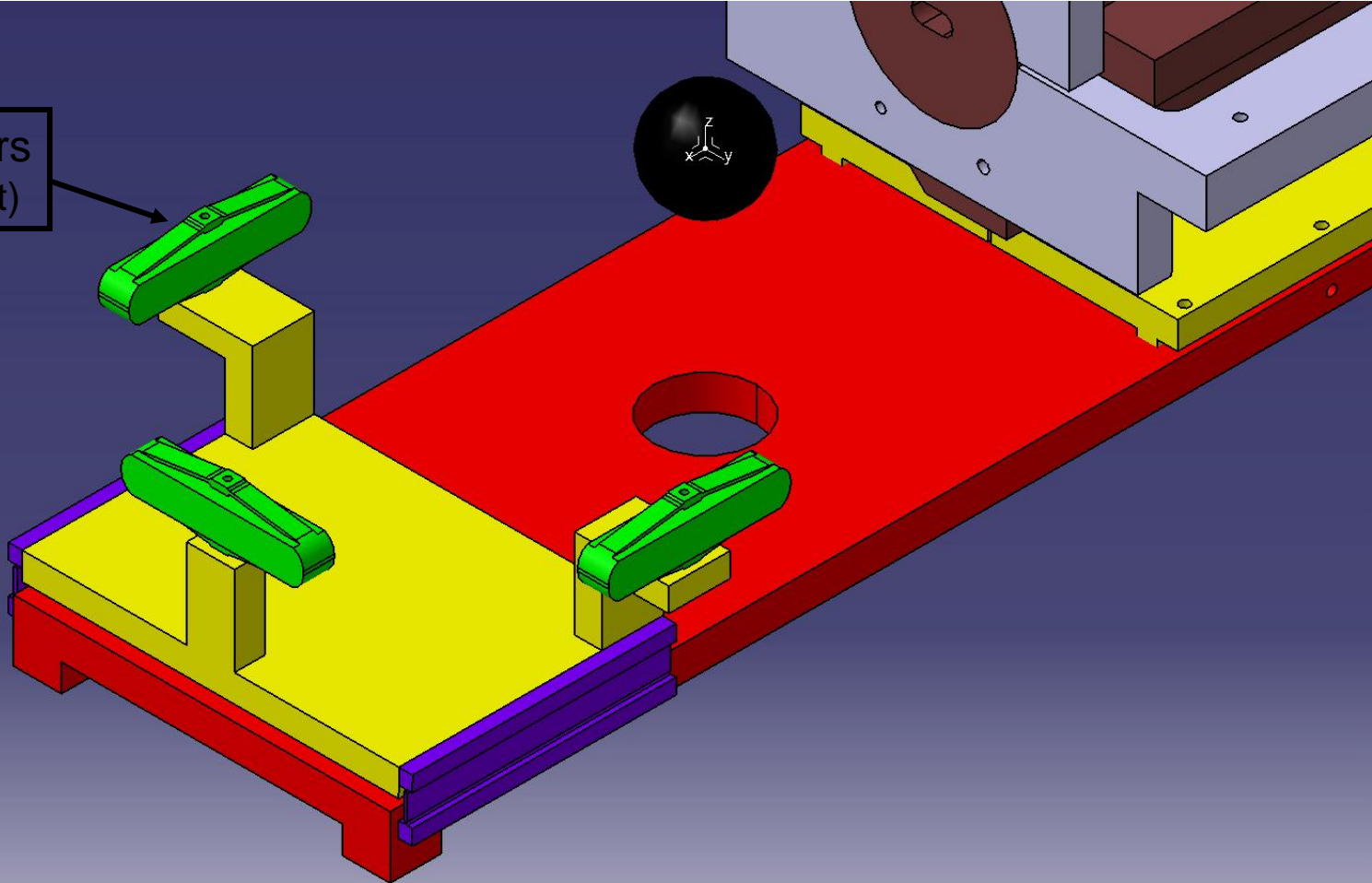


Lateral displacement -2

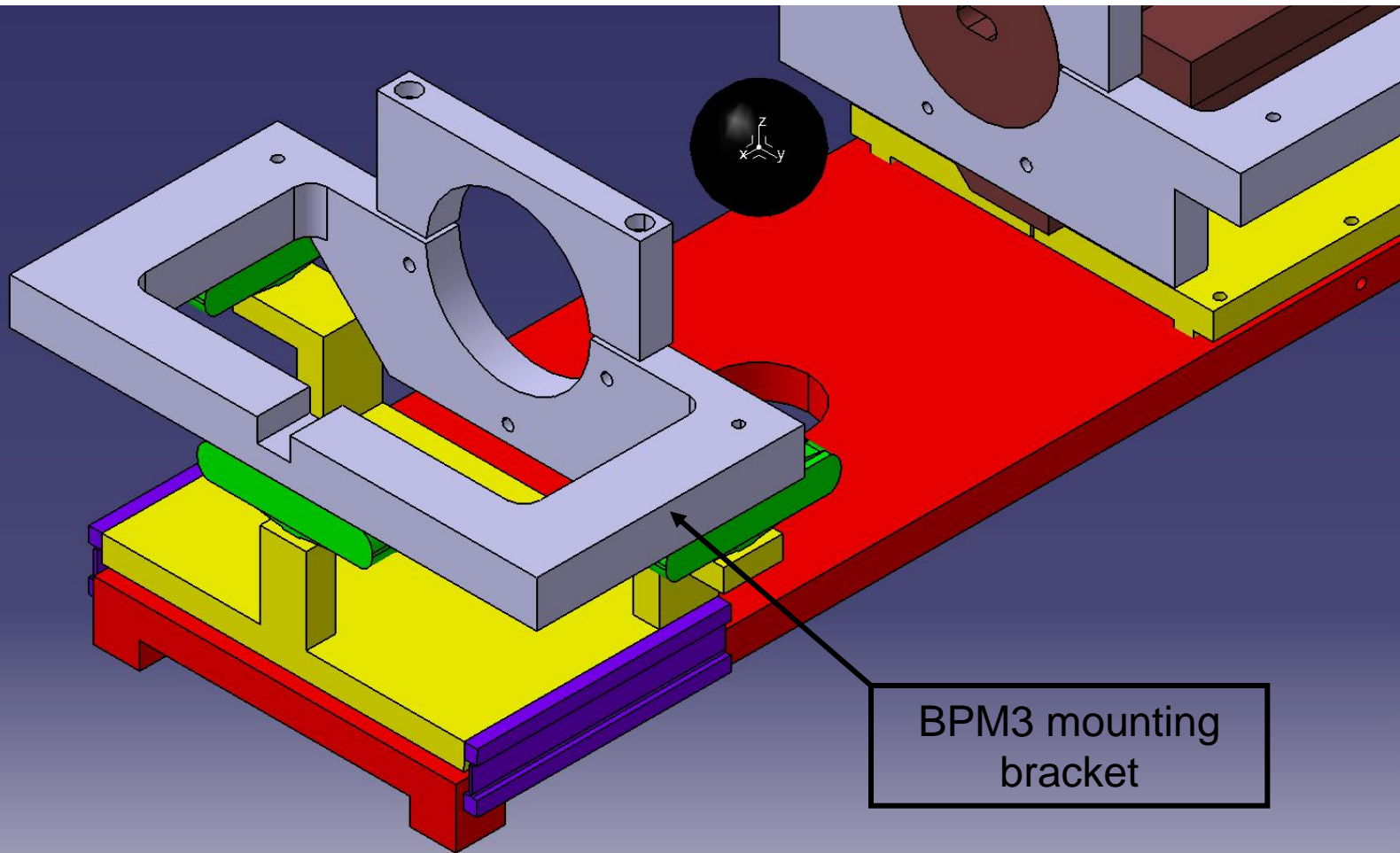


Lateral displacement -3

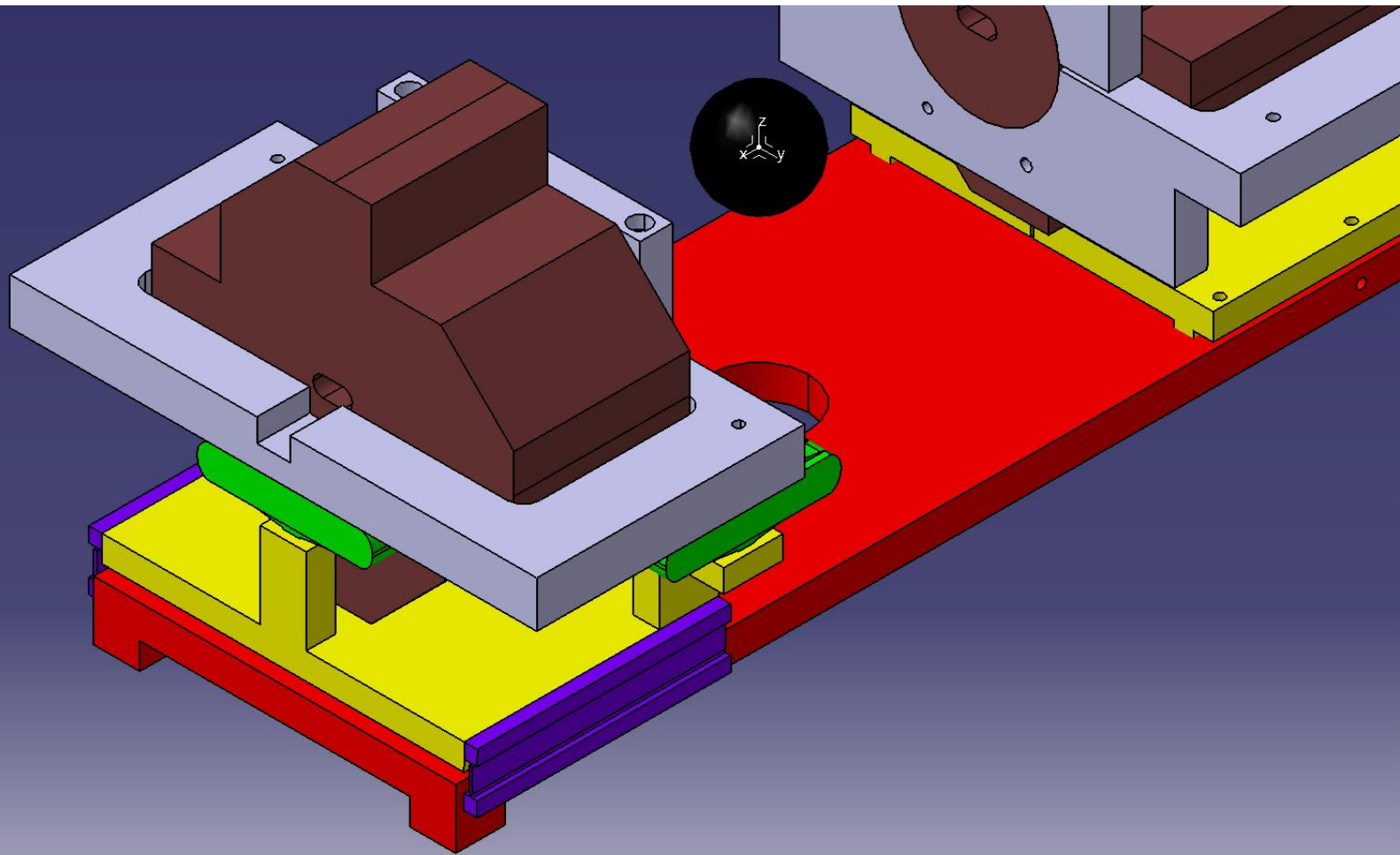
3 Vertical actuators
(enable shift and tilt)



Vertical displacement -1



Vertical displacement -2



Vertical displacement -3

BPM3 displacements with piezo actuators

Piezo actuators (Cedrat APA 200 M) :

- Stroke : 230 μm
- Integrated feedback (strain gauge sensor)
- Actuator resolution : 2.3 nm
- Resolution (actuator + position sensor + controller) : **23 nm** (1/10000 of stroke = strain gauge resolution)
- Accuracy : 230 nm (1/1000 of stroke – close loop including actuator, a sensor position and a controller are necessary to remove the hysteresis)



→ Enable BPM 3 vertical & lateral disp., roll and pitch adjustments

BPM1&2 displacements

Actuators for BPM1&2 will be provided later
(Actuators can be temporary replaced by shims)

How/why to use BPMs displacements

Stroke → BPMs alignment with regard to beam

Accuracy → Calibration

Resolution → BPMs resolution checking ?

Actuators in open loop mode (2.3 nm resolution) ?

How to improve piezo actuator

- Stroke : N/A
- Resolution of 23 nm (strain gauge “resolution”) : **use of capacitive position sensor** (for example external sensor with resolution < 1 nm, i.e. outside the close loop system)
- Accuracy of 230 nm : **use of special controller, capacitive position sensor** (inside the close loop system)

Material and weight

MATERIAL

- IP Chamber vessel and extension viewports : aluminum alloy 5083
- Other parts : FORTAL (high stability aluminum alloy)
→ Aluminum alloy brings weight reduction and good machinability

WEIGHTS

- IP Chamber : 13 kg
- Set of 9 viewports extensions : 3 kg
- BPMs positioning parts : 2 kg
- BPMs : 1 + 2 kg
- Screws, washers, nuts : not calculated

Total Weight : ~21 kg

Schedule

- Delivery at LAL of KNU' BPMs : end of 3/2012
- Delivery at LAL of 4 piezo actuators with electronic for BPM 3 : end of 3/2012
- Piezo actuators tests : 4/2012
 - Dimensional tolerances, stroke...
 - Outgassing
- Order piezo actuators and electronic for BPM1&2 (budget?) : 6/2012
- Manufacturing (with breaks) at LAPP : 4 to 8/2012
- IP Chamber and parts checking : 9/2012
- Assembly process test : 10/2012
- Delivery at KEK : 11-12/2012

Extra slide 1



TECHNICAL DATA SHEET

APA200M

v3.3

CEDRAT
TECHNOLOGIES
15 chemin de Malacher
ZIRST
38246 MEYLAN Cedex
France

Tel. : +33 4 76 90 50 45
Fax : +33 4 56 38 08 30
<http://www.cedrat.com>
actuator@cedrat.com

TABLE OF STANDARD PROPERTIES OF USE AND MEASUREMENT

The properties defined in the table below, are set up according to the technical conditions of use and measurement. These properties are warranted within their variation range and in compliance with the standard technical conditions of use.

Properties APA200M	Standard technical conditions	Unit	Nominal values	Min. values	Max. values
Notes		-	-	-	-
Max. no load displacement	Quasistatic excitation, blocked-free	µm	230	207	299
Blocked force	Quasistatic excitation, blocked-free	N	73	58	88
Stiffness	Quasistatic excitation, blocked-free	N/µm	0,32	0,25	0,36
Resonance frequency (free-free)	Harmonic excitation, blocked-free, on the admittance curve	Hz	4600	3910	5060
Response time (free-free)		ms	0,11	0,10	0,13
Resonance frequency (blocked-free)	Harmonic excitation, free-free, on the admittance curve	Hz	900	765	990
Response time (blocked-free)		ms	0,56	0,50	0,64
Capacitance	Quasistatic excitation, free-free, on the admittance curve	µF	3,15	2,84	4,10
Max. no load displacement at resonance	Max. harmonic excitation, free-free	µm p-p	155	124	186
Max. voltage at resonance	Max. harmonic excitation, free-free	Vrms	9,00	7,20	10,60
Force limit (0-pk)	Max. harmonic excitation, free-free	N	27,38	21,90	30,11
Resolution	Quasistatic excitation	nm	2,30	-	-
Height (in actuation direction)		mm	17,00	16,80	17,20
Length		mm	55,00	54,90	55,10
Width (excl. wedge & wires)		mm	5,00	4,95	5,05
Width (incl. wedge & wires)		mm	9,00	8,00	10,50
Mass		g	15,7	-	-
Standard mechanical interface	2 flat surfaces 5*5 mm ² with M2.5 threaded hole	-	-	-	-
Standard electrical interface	2 PTFE insulated AWG30 wires 100 mm long with Ø 1 banana plug	-	-	-	-

PROPERTIES STANDARD TECHNICAL CONDITIONS OF USE AND MEASUREMENT

- Free-free** : The actuator is not fixed
Blocked-free : The actuator is fixed to a mechanical support assumed infinitely stiff

Extra slide 2

Cedrat - APA200M_GB_v3.3.pdf - Adobe Reader

Fichier Edition Affichage Document Outils Fenêtre Aide

1 / 1 125% Rechercher

Max. voltage at resonance	Max. harmonic excitation, free-free	Vrms	9,00	7,20	10,80
Force limit (0-pk)	Max. harmonic excitation, free-free	N	27,38	21,90	30,11
Resolution	Quasistatic excitation	nm	2,30	-	-
Height (in actuation direction)		mm	17,00	16,80	17,20
Length		mm	55,00	54,90	55,10
Width (excl. wedge & wires)		mm	5,00	4,95	5,05
Width (incl. wedge & wires)		mm	9,00	8,00	10,50
Mass		g	15,7	-	-
Standard mechanical interface	2 flat surfaces 5*5 mm ² with M2.5 threaded hole	-	-	-	-
Standard electrical interface	2 PTFE insulated AWG30 wires 100 mm long with Ø 1 banana plug	-	-	-	-

➤ PROPERTIES STANDARD TECHNICAL CONDITIONS OF USE AND MEASUREMENT

Free-free : The actuator is not fixed
Blocked-free : The actuator is fixed to a mechanical support assumed infinitely stiff
Quasistatic excitation : AC voltage between -20 and 150 V at 1 Hz
Harmonic excitation : Voltage of 0.5 Vrms, sinusoidal mode from 0 to 100 kHz
Max. harmonic excitation : Voltage defined by the measurement of max. displacement, sinus at resonance frequency
Displacement measurement : Laser interferometer, capacitive displacement sensor
Admittance measurement : HP 4194 A or Cypher C60 electrical impedance analyser
Environment : Ambient temperature (15-25°C) and dry air (Humidity < 50 % rH)

Any technical conditions of use, different from those defined above, can lead to temporary or definitive alterations of properties. Thank you to contact CEDRAT TECHNOLOGIES before using actuators under non standard technical conditions.

➤ FACTORY TESTS CARRIED OUT

Test 1 : Electrical admittance vs. Frequency, free-free
 Test 2 : Displacement vs. input voltage

➤ EXTRA FACTORY TESTS

Test 3 : Gain and linearity of the sensor
 Test 4 : Step response in closed loop
 Test 5 : Stability in closed loop

➤ MECHANICAL INTERFACE

[FI] Flat Interface
 [SV] Specific version
 [H] Flat Interface with hole
 [FF] Free-free Interface
 [TH] Flat Interface with threaded hole
 [SI] Specific interface

➤ AVAILABLE OPTIONS

[SG] Strain gauges
 [ECS] Eddy current displacement sensor
 [NM] Non-magnetic sensor
 [VAC] Vacuum

APA200M_GB_v3.3.doc Jan. 2009